

FORM PTO-1449  <b>INFORMATION DISCLOSURE STATEMENT</b>	ATTY. DOCKET 033082 M 334	SERIAL NO. 10/585,828
APPLICANT: Kenji SUZUKI, et al.		
FILING DATE July 12, 2006		GROUP ART UNIT To Be Assigned

## U.S. PATENT DOCUMENTS

Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA	6,130,145	October 10, 2000	Ilg et al.			
	AB	5,913,145	June 15, 1999	Lu et al.			
	AC	5,654,237	August 5, 1997	Suguro et al.			
	AD	5,470,791	November 28, 1995	Suguro et al.			
	AE	5,304,510	April 19, 1994	Suguro et al.			
	AF	5,192,714	March 9, 1993	Suguro et al.			
	AG						

## FOREIGN PATENT DOCUMENTS

Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO	
	AH	11-265992	9/28/1999	JAPAN			abstract	
	AI	11-135455	5/21/1999	JAPAN			abstract	
	AJ	1995-0002169	3/14/1995	KR				
	AK							
	AL							
	AM							
	AN							

## OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

AO	PCT Notification of Transmittal of Copies of Translation of the International Preliminary Examination Report (Form PCT/IB/338) dated January 2004
AP	PCT International Preliminary Report on Patentability (Form PCT/IPEA/409) dated January 2004
AQ	Chinese Office Action issued on April 4, 2008 with English language translation
AR	Korean Office Action issued on May 29, 2007
AS	Korean non-patent document No. 2001-38SD-7-8, Roh et al., "Characteristics of Metal-oxide-Semiconductor (MOS) Devices with....Metal", pages 513-519 (2001)

EXAMINER: /Ermias Woldegeorgis/	DATE CONSIDERED: 05/28/2010
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.